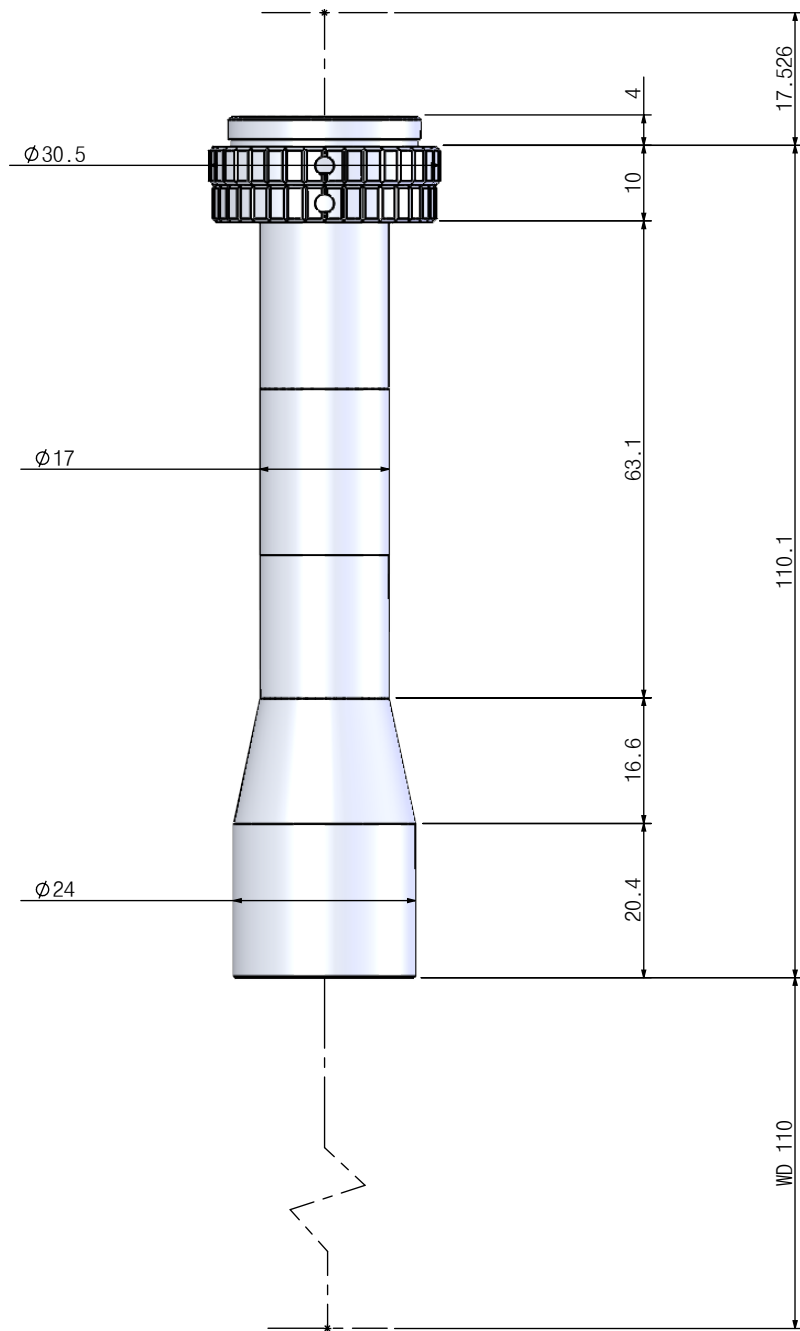


본 도면은 리스광시스템(주)의 자산이므로 허가없이 복제 및 외부 반출을 금함.
 This drawing and ideas are protected by LEES Optical System, Inc.



OPTICAL MAGNIFICATION	WD(mm)	DEPTH OF FIELD	RESOLUTION	NA	PARAXIAL WORKING F/#	F.O.V.	MOUNT
0.8X	110	$\pm 0.55\text{mm}$	7.45 μm	0.045	8.8	H6 mm X V4.5 mm(1/3")	C-MOUNT

CORPORATE NAME		MODEL (ON/COAXIAL)		SCALE
 SINCE 1999		TITLE		1:1
		TLW 110SERIES		DIMENSIONS
		TLW110-0.8X-HR(1/3")		mm